

Docket No.: MUH-12818

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : IOANNIS DOTSIKAS
Filed : CONCURRENTLY HEREWITH
Title : METHOD AND FURNACE FOR THE VAPOR PHASE
DEPOSITION OF COMPONENTS ONTO SEMICONDUCTOR
SUBSTRATES WITH A VARIABLE MAIN FLOW DIRECTION OF
THE PROCESS GAS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:

U.S. Patent No. 5,484,484 (Yamaga et al.), dated January 16, 1996;

U.S. Patent No. 6,045,617 (Keller), dated April 4, 2000 and corresponding German Patent DE 197 43 922 C1 (Keller), dated April 15, 1999;

Patent Abstracts of Japan 63065080 A (Katsuyoshi et al.), dated March 23, 1988.

Respectfully submitted,



For Applicant

LAURENCE A. GREENBERG
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Date: September 30, 2003

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FORM PTO-1449 (SUBSTITUTE) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))				Attorney Docket No.: MUH-12818 Appl. No.: <hr/> Applicant: IOANNIS DOTSIKAS <hr/> Filing Date: September 30, 2003 Group Art Unit:			
EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A	5,484,484	1/16/96	Yamaga et al.			
	B	6,045,617	4/4/00	Keller			
	C						
	D						
	E						
	F						
	G						
	H						
	I						
FOREIGN PATENT DOCUMENT							
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO
	J	197 43 922 C1	4/15/99	Germany			
	K	63065080 A	3/23/88	Japan			
	L						
	M						
	N						
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER				DATE CONSIDERED			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							